

<b>Search Notes</b> 	<b>Application/Control No.</b> 10/724,213	<b>Applicant(s)/Patent under Reexamination</b> OGAWA, YASUSHI
	<b>Examiner</b> Joon H. Hwang	<b>Art Unit</b> 2166

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner